

Figs. 4-27 (a) AES spectra of as-grown CNCs (Specimen B5), where P1 and P2 are detected point of individual CNC as shown in corresponding SEM image (b). The arrowheads are indicate the tip (P1) and bottom (P2) of individual CNC.







(a)

(b)



Figs. 4-28 AES spectra are corresponding to the Figs.4-27 at selective segment.
(a) the AES spectrum of carbon (b) reference spectrum of carbon ^[Lin-01-126]
(c) the AES spectrum of cobalt (d)reference spectrum of cobalt ^[Ferguson-98-63]





Figs. 4-29 (a) TEM bright field image of as-grown CNCs (Specimen B5). ED pattern of (b), (c) and (d) are corresponding to image (a) in select area as indicate by arrowhead.





Figs.4-30 HRTEM images of as-grown CNCs (Specimen B5). image (a) and (b) show the tip of two individual CNCs

(b)

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Remark	Specimen	Applied bias (V)	E _{turn-on} at 10μA/cm ² (V/μm)	E _{threshold} at 10 mA/cm ² (V/μm)	Current density at 10 V/µm (mA/cm ²)
(a)	B2	-50	7.6	not reach	0.28
(b)	B3	-150	8.26	not reach	0.23
(c)	B4	-200	5.76	8.10	58.71
(d)	B5	-300	5.0	6.99	173.42

Table 4-8 FE properties of as-grown CNCs onder different negative applied bias



SpecimenAppliedField Enhancement Factor βbias (V)B5-300

Table 4-9 The field enhancement factor β of as-grown CNCs (Specimen B5)



Fig.4-32 F-N plot of as-grown CNCs (Specimen B5)

